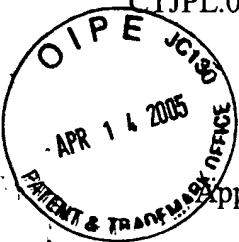


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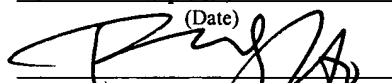
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Jason A. Graetz, et al.
App. No. : 10/660,382
Filed : September 10, 2003
For : HIGH-CAPACITY
NANOSTRUCTURED SILICON
AND LITHIUM ALLOYS
THEREOF
Examiner : Laura S. Weiner

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

April 8, 2005

(Date)


Pui Tong Ho, Reg. No. 44,155

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Our file for the subject application reveals that there has been no action in this application since the Assignment was recorded on February 5, 2004. .

Please inform us as to the status of this application.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: April 8, 2005

By: 

Pui Tong Ho
Registration No. 44,155
Attorney of Record
Customer No. 20,995
(949) 760-0404

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